Attorney Docket No.: SAM-0134

**PATENT** 

Applicant(s):

Jae-Hoon Lee, et al.

Examiner: Kang, D.

Serial No .:

09/737,540

Group Art Unit: 2811

Filing Date:

December 15, 2000

SEMICONDUCTOR DEVICE WIRING AND METHOD OF

MANUFACTURING THE SAME

#### CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

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### AMENDMENT TRANSMITTAL

Sir:

1. Transmitted herewith is an amendment for this application.

# **STATUS**

- 2. Applicant is
  - a small entity.
  - Ø other than small entity.

## **EXTENSION OF TERM**

- The proceedings herein are for a patent application and the provisions of 37 CFR 1.136 3. apply.
- □ Applicant petitions for an extension of time under 37 CFR 1.136 (a)